

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

KAMIYAMA et al.

Application No. Unassigned

Filed: March 30, 2004

Art Unit: Unassigned

Examiner: Unassigned

For: SEMICONDUCTOR DEVICE, METHOD  
FOR MANUFACTURING THE SAME,  
APPARATUS FOR FORMING FILM, AND  
METHOD FOR FORMING HIGH-  
DIELECTRIC-CONSTANT FILM

**PRELIMINARY AMENDMENT**

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Prior to the examination of the above-identified patent application, please enter the following amendments and consider the following remarks.